

FORM PTO-1449 INFORMATION DISCLOSURE CITATION	Atty Docket 21994/0040	Serial No. To be assigned
	Applicant Mikio OKUMURA et al.	
	Filing Date Herewith	Group Art Unit To be assigned

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
<i>PM</i>	AA	6,198,565	03/2001	Iseki et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AL						Yes No
	AM						Yes No
	AN						Yes No
	AO						Yes No
	AP						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	Y. Yee et al., "PZT Actuated Micromirror For Nano-Tracking Of Laser Beam For High-Density Optical Data Storage", IEEE MEMS2000, January 2000, pps. 435-440
	AS	
	AT	

Examiner <i>Peter Macchiaro</i>	Date Considered 4.5.04
---------------------------------	------------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 600. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant(s).